

Application Data Sheet**Application Information**

Application Type:: Regular
Subject Matter:: Utility
CD-ROM or CD-R: None
Title:: METHOD FOR FABRICATING A FE-SI BASED
THIN FILM, AND FE-SI BASED THIN FILM
Attorney Docket Number:: 118365
Suggested Drawing Figure::
Total Drawing Sheets:: 4
Small Entity:: Yes

Applicant Information

Applicant Authority type:: Inventor
Primary Citizenship Country:: Japan
Status:: Full Capacity
Given Name:: Hiroshi
Family Name:: FUNAKUBO
City of Residence:: Kawasaki City
Country of Residence:: JAPAN

Correspondence Information

Correspondence Customer Number:: 25944

Foreign Priority Information			
Country::	Application Number::	Filing Date::	Priority Claimed::
JAPAN	2003-106784	4/10/2003	Yes
Assignee Information			
Assignee Name::		TOKYO INSTITUTE OF TECHNOLOGY	
Street of mailing address::		2-12-1, Ookayama, Meguro-ku,	
City of mailing address::		Tokyo	
Country of mailing address::		JAPAN	